1763#

SEP 10 2001 AND SEP 10 2001

Case Docket No. ASMEX.236A

I hereby certify that this correspondence and all marked

attachments are being deposited with the United States Postal Service as first class mail in an envelope addressed to:

Assistant Commissioner for Patents, Washington, D.C.

September 5, 2001

20231, on

Date: September 5, 2001 Page 1

In re application of:

Raaijmakers et al.

App. No.

09/658,784

Filed

September 11, 2000

For

LOADLOCK WITH

INTEGRATED PRE-

CLEAN CHAMBER

Examiner

R. Zervigon

Art Unit

1763

ASSISTANT COMMISSIONER FOR PATENTS

RECEIVED

SEP 1 4 2001

Sir:

Transmitted herewith is an amendment in the above-identified application.

TC 1700

The fee has been calculated as shown below:

WASHINGTON, D.C. 20231

		CI	LAIMS AS FILED			•
-	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDITIONAL FEE
Total Claims	33		65	= 0 ×	\$18	= \$0
Independent Claims	8	 ;	3	= 5 ×	\$80	= \$400
If application has bee dependent claim(s),		ıtain multip	le		\$270	= \$0
Time Extension Fee			·	•		\$0
·	··········			TOTAL ADD	ITIONAL E	EE

FOR THIS AMENDMENT

\$400

(X) Return prepaid postcard.

(X) A check in the amount of \$400 is enclosed.

(X) Please charge any additional fees, including any fees for additional extension of time, or credit overpayment to Deposit Account No. 11-1410.

Gordon H. Olson

Registration No. 20,319

Attorney of Record

PATENT

TRAINMENE	UNITED	STATES	PATENT AND) TRADEMARK	OFFICE
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Applicant

Raaijmakers et al.

Appl. No.

09/658,784

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R. Zervigon

AMENDMENT

Assistant Commissioner for Patents Washington, D.C. 20231

Dear Sir:

In response to the Office Action mailed June 5, 2001, Applicant respectfully submits the following amendments and comments in connection with the above-captioned application.

IN THE CLAIMS:

Please amend Claims 1, 2, 7, 11, 14-17, 19, 22 57, 61 and 62 as follows:

(AMENDED) A load lock that defines at least partially a first chamber and an auxiliary chamber, said load lock comprising:

a first port and a second port, said first and second ports for moving a wafer into and out of said load lock;

an elevator plate including a wafer carrier that is adapted for receiving a plurality of wafers and is attached to said elevator plate; and

said wafer carrier and said elevator plate being moveable between a first position where said wafer carrier is in said first chamber and a second position where said wafer carrier is in said auxiliary chamber and said elevator plate substantially seals said auxiliary chamber from said first chamber.

01 FC:102

400.00 DP

Group Art Unit: 1763

Washington, D.C. 20231, on

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September 5, 2001

09/13/2001 TBESHAH1 00000025 09658784